## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Patent Examiner: Chacko Davis, Daborah

Howard Ge, et al.

Group Art Unit: 1795

Serial No.: 10/680,960

10.. 10,000,500

Filed: October 7, 2003

Title: PHOTORESIST COATING PROCESS

FOR MICROLITHOGRAPHY

March 10, 2008

Costa Mesa, California 92626

## **RESPONSE TO OFFICE ACTION**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of November 16, 2007, kindly amend the above identified application as follows: